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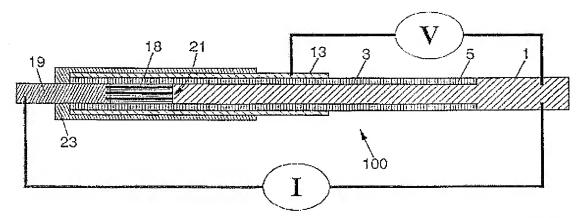
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(54) Title: METHOD FOR PRODUCING ELECTRONIC COMPONENTS AND ELECTRONIC COMPONENTS PRODUCE BY SAID METHOD

(54) Time : PROCEDE DE FABRICATION DE COMPOSANTS ELECTRONIQUES ET COMPOSANTS ELECTRONIQUES OBTENUS PAR CE PROCEDE



- (57) Abstract: The invention relates to a method for producing electronic components consisting in carrying out a first anothsation of a carrier material (1) for forming at least one first pore (3) extending in a first direction in said carrier material (1) and in carrying out a second anodisation for forming at least one second pure (17) extending in the carrier material (1) in a second direction different from the first direction
- (57) Abrégé : Il s'agit d'un procédé de fabrication de composants pour l'électronique dans lequel on réalise une première anodisation d'un matériau support (1) pour former nu moins un premier pore (3) s'étendant, dans ce matériau support (1) dans une première direction. En outre, on réalise une deuxième anodisation pour former au moins un deuxième pore (17) s'étendant dans le matériau support (1) dans une deuxième direction différente de la première direction.

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